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SERIAL NUMBER 10/774,701	FILING OR 371(c) DATE 02/10/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 049128-5144
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

*none I do not*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*REPUBLIC OF KOREA 2003-8159 02/10/2003*  
*REPUBLIC OF KOREA 2003-19782 03/29/2003*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

04/10/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 50	TOTAL CLAIMS 87	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				

Verified and Acknowledged *L. de la Rosa*

Examiner's Signature

Initials

## ADDRESS

09629

## TITLE

Method of patterning transparent conductive film, thin film transistor substrate using the same and fabricating method thereof

FILING FEE RECEIVED 2364	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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